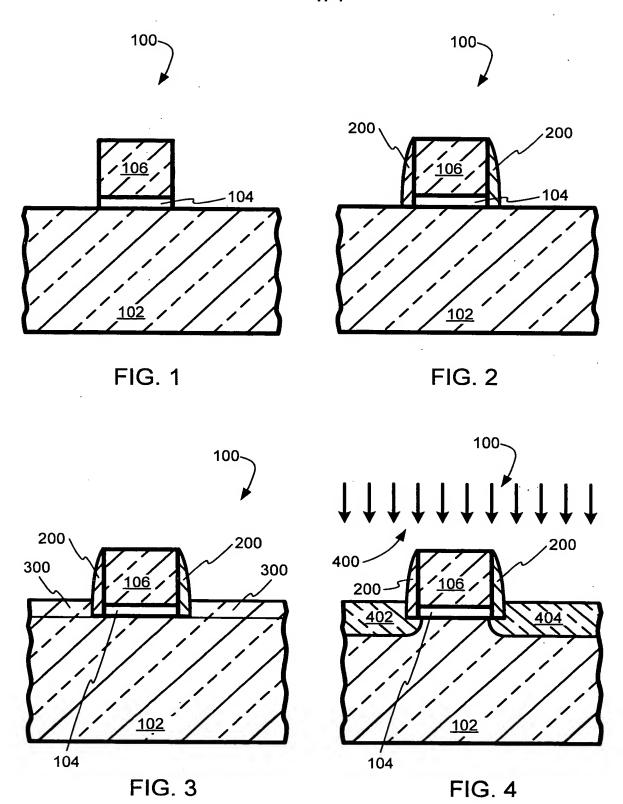
Page 1 of 4

Title: FORMATION OF ABRUPT JUNCTIONS IN DEVICES BY USING SILICIDE GROWTH DOPANT SNOWPLOW EFFECT

Inventor: Witold P. Maszara

Docket No.: H1855 Contact: Mikio Ishimaru (408) 738-0592

## 1/4

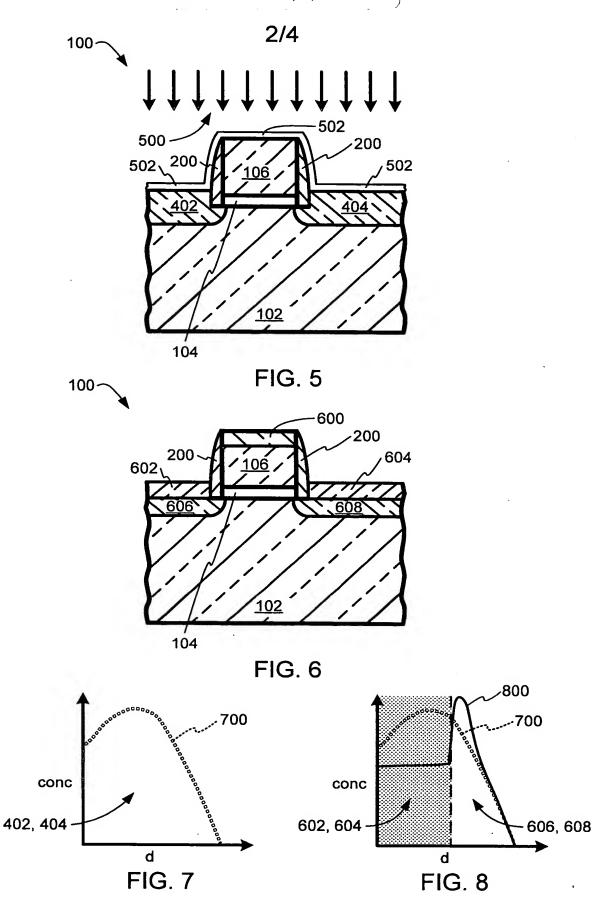


Page 2 of 4 Title: FORMATION OF ABRUPT JUNCTIONS IN

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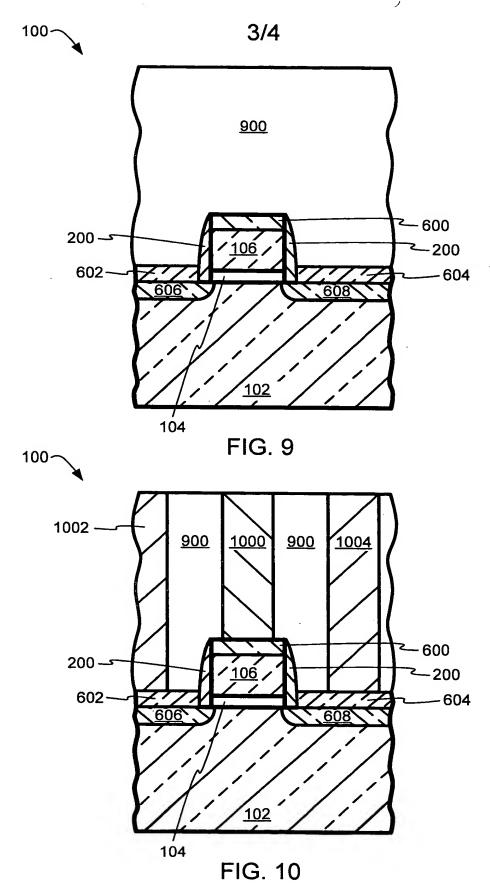
Page 3 of 4

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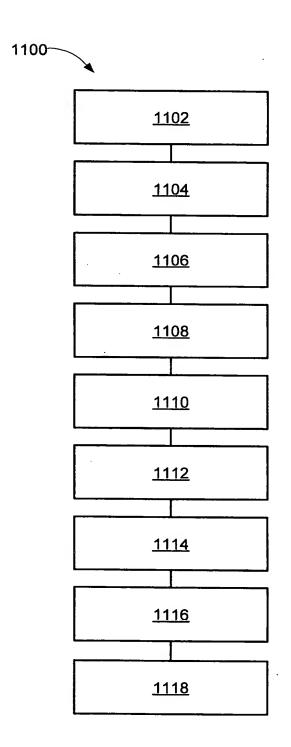
Page 4 of 4

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4/4



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FIG. 11